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Express Mail No.: EL 451 597 892 US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of: Steven M. Chase, Connie J. Chang-Hasnain and Jeffrey M. Waite

Application No.: 09/693,612

Group Art Unit: 2872

Filed: October 20, 2000

Examiner: Ricky D. Shafer

For:

Apparatus and Method for

Attorney Docket No.: 9840-0053-999

Controlled Cantilever

Motion Through Torsional Beams and a Counterweight

Date: July 24, 2002

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AMENDMENT AND RESPONSE TO OFFICE ACTION

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

Enclosed is an amendment responsive to the Office Action dated June 28, 2002, for the above identified patent application.

The Commissioner is hereby authorized to charge all fees that may be required, to Deposit Account No. 16-1150 (Order No. 9840-0053-999). A copy of this page is enclosed.

Respectfully submitted,

Date:

Gary S. Williams

31,066

(Reg. No.)

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AMENDMENT AND RESPONSE TO OFFICE ACTION

Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

This communication is responsive to the Office Action dated June 28, 2002, for the above identified patent application. A response is due September 28, 2002. Please amend the application as follows.

IN THE CLAIMS:

Cancel claim 28.

Claims 8-11 and 16-19 were withdrawn by the Examiner.

Revisions to the claims are shown in Appendix A.

Rewrite the pending claims as follows:

1. (amended) An optical micro-electromechanical device, comprising:

a substrate; and

a mirror assembly suspended above said substrate, <u>said substrate and said mirror</u> together forming a Fabry-Perot cavity, said mirror assembly including:

a torsional beam attached to said substrate,

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